

09/8/3240

ABSTRACT OF THE DISCLOSURE

A semiconductor wafer made from silicon which is doped with hydrogen. The hydrogen concentration is less than 5×10^{16} atcm⁻³ and greater than 1×10^{12} atcm⁻³. A method for producing a semiconductor wafer from silicon includes separating the semiconductor wafer from a silicon single crystal, with the single silicon crystal being pulled from a melt, in the presence of hydrogen, using the Czochralski method. The hydrogen partial pressure during the pulling of the single silicon crystal is less than 3 mbar.

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